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## \*BIBDATASHEET\*

Bib Data Sheet

CONFIRMATION NO. 1762

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## APPLICANTS

Gerbrand Van Der Zouw, Eindhoven, NETHERLANDS;

## \*\* CONTINUING DATA \*\*\*\*\*

## \*\* FOREIGN APPLICATIONS \*\*\*\*\*

EUROPEAN PATENT OFFICE (EPO) 03075431.1 02/14/2003

## IF REQUIRED, FOREIGN FILING LICENSE GRANTED

\*\* 05/08/2004

Foreign Priority claimed 35 USC 119 (a-d) conditions met	✓ yes <input type="checkbox"/> no ✓ yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance	STATE OR COUNTRY NETHERLANDS	SHEETS DRAWING 4	TOTAL CLAIMS 26	INDEPENDENT CLAIMS 4
Verified and Acknowledged Examiner's Signature	HJ				

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## TITLE

Lithographic device and method for wafer alignment with reduced tilt sensitivity

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